

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/786,495

Confirmation No.: 3146

In re application of: Chun-Hung LIN

Filed: February 25, 2004

Technology Center/Art Unit: 2886

Examiner: NGUYEN, Sang H

Docket No.: 2003-0671(N1085-00243)

Customer No.: **54657**

Title: METHOD TO PREDICT AND
IDENTIFY DEFOCUS WAFERS

I CERTIFY THAT THIS CORRESPONDENCE IS BEING
TRANSMITTED ELECTRONICALLY TO THE UNITED STATES
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21 May 2007


SIGNATURE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This is in response to the Restriction Requirement in the Office Action dated **April 17, 2007**.

Remarks/Arguments begin on page 2 of this paper.